



CyberOptics Showcases High-Precision Humidity Measurement Sensor at SEMICON China

Measurement Portfolio Saves Semiconductor Manufacturers Time and Expenses While Improving Yields

Shanghai, China— March 10th, 2016— [CyberOptics® Corporation](#) (NASDAQ: CYBE), a leading global developer and manufacturer of high precision 3D sensing technology solutions, will showcase WaferSense® and ReticleSense® Auto Multi Sensors (AMS) at [SEMICON China](#), March 15-17, 2015 in the PSC and KNG booth #3358 and the Winifred booth #1461.

The WaferSense and ReticleSense Auto Multi Sensor (AMS/AMSR) line measures relative humidity (RH) in real time. Process and equipment engineers can also measure vibration and leveling using this measurement device. With its thin and light form factor, CyberOptics' AMS can travel through virtually any tool and the AMSR can be used in any reticle environment.

“The Auto Multi Sensor devices are yet another way to increase yield and reduce dreaded downtime in semiconductor environments, saving our customers both time and money,” said Dr. Subodh Kulkarni, President and CEO, CyberOptics.

CyberOptics will also feature the new Airborne Particle Sensor (APS2) devices that improve equipment set-up and long-term yields in semiconductor fabs by wireless monitoring airborne particles in real-time. The new APS2 quickly monitors, identifies and enables troubleshooting of airborne particles down to .14um within semiconductor process equipment and automated material handling systems. It easily identifies when and where the particles originate and speeds equipment qualification with wireless measurements, shortens equipment maintenance cycles with wafer-like and reticle form factors and lowers equipment expenses by providing objective and reproducible data.

About the CyberOptic WaferSense and ReticleSense Line

The WaferSense measurement portfolio including the Auto Leveling System (ALS), the Auto Gapping System (AGS), the Auto Vibration System (AVS), the Auto Teaching System (ATS), the Airborne Particle Sensor (APS), the next-generation Airborne Particle Sensor (APS2) and the new Auto Multi Sensor (AMS) are available in various wafer shaped form factors depending on the device, including 150mm, 200mm, 300mm and 450mm wafer sizes. The ReticleSense measurement portfolio including the Airborne Particle Sensor (APSR & APSRQ) and next-generation APS2, the Auto Leveling System (ALSR) and the new Auto Multi Sensor (AMSR) are available in a reticle shaped form factor.

For more information about the entire line of CyberOptics' solutions please visit the company's website at www.cyberoptics.com.

About CyberOptics

CyberOptics Corporation (NASDAQ: CYBE) is a leading global developer and manufacturer of high precision sensing technology solutions. CyberOptics sensors are being used in general purpose metrology and 3D scanning, surface mount technology (SMT) and semiconductor markets to significantly improve yields and productivity. By leveraging its leading edge technologies, the company has strategically established itself as a global leader in high precision 3D sensors, allowing CyberOptics to further increase its penetration of its key vertical segments. Headquartered in Minneapolis, Minnesota, CyberOptics conducts worldwide operations through its facilities in North America, Asia and Europe.

Statements regarding the Company's anticipated performance are forward-looking and therefore involve risks and uncertainties, including but not limited to: market conditions in the global SMT and semiconductor capital equipment industries; increasing price competition and price pressure on our product sales, particularly our SMT systems; the level of orders from our OEM customers; the availability of parts required to meet customer orders; unanticipated product development challenges; the effect of world events on our sales, the majority of which are from foreign customers; rapid changes in technology in the electronics markets; product introductions and pricing by our competitors; the success of our 3D technology initiatives and other factors set forth in the Company's filings with the Securities and Exchange Commission.

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